

Search Notes

Application/Control No.

10/646,615

Examiner

Taeyoon Kim

Applicant(s)/Patent under
Reexamination

HENNEN, WILLIAM J.

Art Unit

1651

SEARCHED

Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
updated search	6/23/2008	TK